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J. R. R. R.
PATENTS
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
SATOSHI KITAGAWA)
)
Filed: October 25, 2000)
)
For: MARKING METHOD FOR)
SEMICONDUCTOR WAFER)

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

The citation of information on the attached Form PTO-1449, "List of Art Cited by Applicant" is made pursuant to 37 C.F.R. §§ 1.56, 1.97, and 1.98. Copies of each cited item are enclosed.


An English-language translation of the Abstract of each cited document also is enclosed.

The citation of this information does not constitute an admission of priority or that any cited item is available as a reference, or a waiver of any right the

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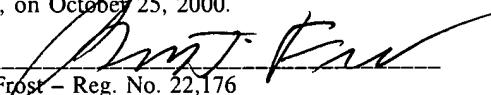
Respectfully submitted,

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